

<b>Notice of References Cited</b>	Application/Control No. 10/664,635	Applicant(s)/Patent Under Reexamination NAKAMURA, MITSUHIRO	
	Examiner HIEU T. HOANG	Art Unit 2152	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,956,821	10-2005	Szviatovszki et al.	370/237
	B	US-			
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	D	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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